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November 28, 2003

In Affiliation with
Weiss, Moy & Harris, PC
having offices in Arizona and Nevada,
and in Washington, DC with
Rabin & Berdo, PC



Mail Stop Patent Application

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Re:

New Patent Application of: Makoto TERUI

Title:

SEMICONDUCTOR DEVICE WITH IMPROVED DESIGN FREEDOM OF

Attorney Reference: OHG 148

EXTERNAL TERMINAL

Sir:

Please find attached hereto an application for patent that includes:

- [x] Specification, Claims and Abstract (60 Pages)
- [x] 10 Sheets of Formal Drawings (Figs. 1 10)
- [x] Claim for priority (one priority document to be submitted later).

The right of priority is claimed under 35 USC §119 of Japanese Application No. JP 193261/2003 FILED July 8, 2003 (document to be submitted later).

Respectfully submitted,

November 28, 2003

Date

Steven M. Rabin (Reg. No. 29,102)

Customer No. 23995

SMR:pjl